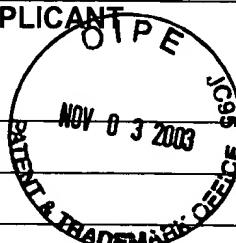


U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)					Docket No. 5017/ISM/CORE /MCVD/SB	Serial No. 09/917,842
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant Chin, et al.	Confirmation No.: 3573
(Use several sheets if necessary)					Filing Date July 27, 2001	Group 2125
Examiner Kosowski, A.						

**U.S. Patent Documents**

*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
ASR	A1	6,342,277	01/29/02	Sherman	427	562	04/14/99
	A2	6,319,553	11/20/01	McInerney, et al.	427	250	02/28/00
	A3	6,206,967	03/27/01	Mak, et al.	118	666	06/14/00
	A4	6,203,613	03/20/01	Gates, et al.	117	104	10/19/99
	A5	6,143,659	11/07/00	Leem	438	688	08/27/98
	A6	6,143,082	11/07/00	McInerney, et al.	118	719	10/08/98
	A7	6,139,700	10/31/00	Kang, et al.	204	192.17	09/30/98
	A8	6,042,652	03/28/00	Hyun, et al.	118	719	09/07/99
	A9	6,026,589	02/22/00	Yao, et al.	34	78	02/02/98
	A10	5,916,365	06/29/99	Sherman	117	92	08/16/96
	A11	2001/0054769	12/27/01	Raaijmakers, et al.	257	758	04/26/01
	A12	2001/0041250	11/15/01	Werkhoven, et al.	428	212	03/06/01
↓	A13	2001/0024387	09/27/01	Raaijmakers, et al.	365	200	02/22/01

Foreign Patent Documents

*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation/Abstract	
							YES	NO
ASR	B1	2002 2060944	02/28/02	JP	C23C	16/30	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B2	01/29893	04/26/01	WO	H01L	21/768	<input type="checkbox"/>	<input type="checkbox"/>
	B3	01/29891	04/26/01	WO	H01L	21/768	<input type="checkbox"/>	<input type="checkbox"/>
	B4	01/27347	04/19/01	WO	C23C	16/44	<input type="checkbox"/>	<input type="checkbox"/>
↓	B5	01/27346	04/19/01	WO	C23C	16/44	<input type="checkbox"/>	<input type="checkbox"/>

OTHER ART

*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.
ASR	C1	Klaus, et al., "Atomically controlled growth of tungsten and tungsten nitride using sequential surface reactions," Applied Surface Science 162-163 (2000) 479-491
	C2	
Examiner	<i>Alley Kosowski</i>	Date Considered <i>11/18/03</i>

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.